ABSTRACT OF THE DISCLOSURE

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2 A method for preparing thin integrated circuits having multiple circuit layers has the following acts of: forming a first circuit layer on a 3 substrate; depositing at least one resin and copper layer on the first circuit 5 layer; forming a second circuit layer on the at least one resin and copper layer; electrically connecting the first and second circuit layers; attaching 6 electronic components to the first or second circuit layers; applying an 7 8 encapsulant layer to protect the electronic components; and removing the substrate to expose the first circuit layer. By removing the substrate, the 9 10 integrated circuit is much thinner.